



Docket No.: M4065.0319/P319
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Ronald A. Weimer, et al.

Examiner: Erik Kielin

Application No.: 09/296,835

Art Unit: 2813

Filed: April 22, 1999

For: METHOD OF FABRICATING A
SEMICONDUCTOR DEVICE WITH A
DIELECTRIC FILM USING A WET
OXIDATION WITH STEAM PROCESS

AMENDMENT IN RESPONSE TO AFTER-FINAL OFFICE ACTION

Commissioner for Patents
MS: Amendment
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This paper is in response to the Office Action dated January 11, 2005. Please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

DO NOT ENTER, ERK, 4/15/2005